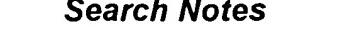


Search Notes	Application/Control No.	Applicant(s)/Patent under Reexamination
	09/854,463	HANNUKSELA ET AL.
	Examiner	Art Unit
	Erick Rekstad	2621

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
IEEE: error <and> concealment <and> video	5/27/2005	ER
IEEE, ACM Digital Library, CiteSeer, Optics Information Database search for (.h.263 and supplemental enhancement)	11/14/2005	ER
keyword search	7/21/2004	ER
keyword search	5/27/2005	ER
keyword search	11/14/2005	ER
keyword search	9/1/2006	ER
keyword search	12/10/2006	ER